Research Article

Enhancement and Quenching of Fluorescence by Silver Nanoparticles in Organic Light-Emitting Diodes

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The influence of silver nanoparticles (SNPs) on the performance of organic light-emitting diodes (OLEDs) is investigated in this study. The SNPs are introduced between the electron-transport layers by means of thermal evaporation. SNPs are found to have the surface plasmon resonance at wavelength 525 nm when the mean particle size of SNPs is 34 nm. The optimized OLED, in terms of the spacing between the emitting layer and SNPs, is found to have the maximum luminance 2.4 times higher than that in the OLED without SNPs. The energy transfer between exciton and surface plasmons with the different spacing distances has been studied.

1. Introduction

The organic light-emitting diode (OLED) has displayed significant potentiality in the applications of flat panel display and lighting, which is mainly because of its low power consumption. Various means have been developed to optimize OLED’s efficiency, for example, doping the hole-transporting materials or inserting the hole-blocking layer to decrease hole mobility and balance hole/electrons ratio in emitting layer (EML) of device [1–3], doping phosphorescence material into the EML to increase the quantum efficiency by taking advantage of triplet state recombination [4–6], or improving the hole/electron balance by increasing electron injection [7, 8]. However, those methods increased the complexity of device structure which increases the fabrication time and cost of device.

Recently, in view of the luminance enhancement effect of surface plasmon (SP), the surface plasmon resonance effect (SPRE) of metal nanoparticles has been actively studied in both OLED and inorganic light-emitting diode in [9–12]. It is well known that the SPRE was induced by interaction between the surface charge of metal and the electromagnetic field of the incident light [13]. When the metal surface is close to the fluorescent molecule, the luminous efficiency of the fluorescent molecule can be significantly enhanced. Nevertheless, the nonradiative quenching of exciton at the metal surface occurs when the distance is much smaller than the fluorescent molecule and the metal surface. Therefore, two competitive processes take place in an exciton-SP system: (i) increase in radiative intensity by subtraction in decay time of exciton and (ii) nonradiative quenching of exciton by energy transfer to the metal surface. Therefore, the distances between the fluorescent molecule and the metal surface are a very important parameter in terms of the coupling between the SPs and excitons.

The silver nanoparticles (SNPs) layer was incorporated as an interlayer between the electron-transport layer and the electrode, which can improve the efficiency of OLEDs [14]. Nevertheless, the causes of nonradiative quenching and efficiency improvement at different distances between the silver nanoparticles and electron-transport layer were not described in detail. In this paper, the distance of the SNPs...
from the EML has been optimized for enhancement of maximum luminescence, and how the distances between the SNPs and the EML influenced the enhancement of device luminescence was also observed. Furthermore, mechanisms of increase in radiative intensity and nonradiative quenching have been described in detail.

2. Experimental

The schematic structure of OLEDs is shown in Figure 1. Indium tin oxide (ITO) coated on glass with a sheet resistance of 10 Ω/sq was used as the starting substrate. The substrate was cleaned with acetone, methanol, and deionized water and then dried with nitrogen gas. After the cleaning process, the substrates were loaded into a thermal evaporator. Afterward, N,N’-bis-(1-naphthyl)-N,N-diphenyl-1,1’-biphenyl-4-diamine (NPB; 35 nm), tris-(8-hydroxyquinoline) aluminum (Alq3; 40 nm), 4,7-diphenyl-1,10-phenanthroline (BPhen; X nm), SNPs, BPhen (13-X nm), lithium fluoride (LiF; 0.5 nm), and aluminum (Al; 100 nm) were deposited. NPB and BPhen were used as the hole and electron-transport layers, respectively. Alq3 has been used as EML. LiF, Al, and ITO have been used as the electron-injection layer, cathode, and anode, respectively. In addition, the SNCs were fabricated by thermal evaporation of silver slug. The deposition rate and the deposition time are 0.01 nm/s and 300 seconds. During the deposition, the base pressure of the chamber was maintained at as low as 2.4 × 10⁻⁶ Torr. The active area of the device was 6 × 6 mm². The deposition rates of all organic materials were maintained at 0.01 nm/s, except for the Al whose deposition rate was 0.5 nm/s. The thickness of the layers is controlled by using a quartz-crystal monitor in this work. The current density-voltage (J-V) and luminance-voltage (L-V) characteristics of the devices were measured by using a Keithley 2400 (Keithley Instruments, Inc., USA) and a PR-655 (Photo Research, Inc., USA), respectively. The absorption spectrum was measured by using a U-3900 spectrophotometer (Hitachi, Japan). The photoluminescence (PL) spectrum and scanning electron microscope (SEM) images were measured by using an IK series (Kimmon Koha, Japan) and a JSM-6700F (JEOL, Japan). All measurements were made at room temperature under ambient air.

3. Results and Discussion

Figure 2(a) shows the SEM image of SNPs on a glass substrate. The mean particle size of SNPs in Figure 2(a) was calculated and found to be 34 nm. In addition, the size distribution of the SNCs is plotted in the inset of Figure 2(a). It is observed that the size distribution of the SNCs is from 21 to 45 nm. The absorption spectrum of SNPs with a mean particle size of 34 nm and the PL spectrum of Alq3 are shown in Figure 2(b). It is observed that the absorption spectrum of SNPs with a mean particle size of 34 nm is about 523 nm and the PL spectrum of Alq3 is about 523 nm. Furthermore, it can be seen that there is a significant overlap between the absorption spectrum of the SNPs and PL spectrum of Alq3. It is well known that the excellent overlap between the two spectra suggests that they can be used for SP-exciton coupling. In other words, this overlap implied that these SNPs can be used to increase the characters of OLEDs.
The distance between the fluorescent molecule and the SNPs is a very important parameter in terms of the coupling between the SPs and excitons. Therefore, the distance was tuned by changing the thickness of the spacing layer (BPhen). The \( J-V \) curves of the devices without SNPs and with different spacing distances between EML and SNPs are plotted in Figure 3(a). It can be clearly seen that the current density of the devices with SNPs at thickness of spacing \( \geq 7 \text{ nm} \) is higher than that of devices without SNPs because the localized electric field around the SNPs is enhanced, resulting in an increase in electron injection from cathode electrode. Figure 3(b) shows the \( L-V \) characteristic of the devices without SNPs and with different spacing distances between EML and SNPs. It is observed that the luminance of the devices was increased with a decrease in thickness of the spacing layer, in the condition of thickness of spacing \( \geq 7 \text{ nm} \), because the surface-plasmon-enhanced spontaneous emission rate of SNPs is enhanced when the SNPs are close to the EML. In addition, the luminance of the device without a spacing layer is quite low compared with that of the device without SNPs, because the SNPs will penetrate considerably into EML.

To further confirm the relationship between the penetration of the SNPs and the luminance of the device, the X-ray photoelectron spectrometry (XPS) depth profile of silver is measured in this paper. The samples for analysis of XPS depth profile are prepared as follows: (I) ITO/Alq\(_3\) (15 nm)/SNPs and (II) ITO/Alq\(_3\) (15 nm)/BPhen (13 nm)/SNPs. Figures 4(a) and 4(b) show the XPS depth profile of silver from structures I and II, respectively. Structures I and II are plotted in the inset of Figures 3(a) and 3(b), respectively. It can be clearly seen that the intensity of the SNPs into the EML of the structure II is quite low, compared with that of structure I because structure II has a spacing layer which can impede
HOMO
Electron transfer
SNP
LUMO
Alq3

Electron transfer

Figure 5: Schematic diagram of emission quenching process.

Figure 6: Enhancement factor and Förster energy transfer efficiency for different spacing distances between EML and SNPs.

the SNPs penetration into EML. Moreover, the emission quenching was caused when the SNPs penetrated into EML. The schematic diagram of the emission quenching process is shown in Figure 5. The emission quenching mainly resulted from the electron transfer from the lowest unoccupied molecular orbital (LUMO) of Alq3 to the Fermi level of the SNPs. Furthermore, the exciton is unable to be generated when the electron transfers from the LUMO of Alq3 to the Fermi level of the SNPs [15]. Therefore, when the SNPs penetrated into Alq3, the emission quenching of the device was caused. The enhancement and quenching of the device are a consequence of the interplay between the increase in radiative intensity by SPRE of SNPs and the emission quenching by electron transfer from the Alq3 to the SNPs.

Figure 6 shows the plots of the enhancement factor and the Förster energy transfer efficiency as a function of the spacing distance. The enhancement factor is expressed as $L_2/L_1$, where $L_2$ is the maximum luminance of the device with SNPs and $L_1$ is the maximum luminance of the device without SNPs. It is observed that the enhancement factors were increased with a decrease in thickness of the spacing layer, in the condition of thickness of spacing $\geq 7$ nm because the surface-plasmon-enhanced spontaneous emission rate of SNPs is enhanced when the SNPs are close to the EML. Furthermore, when the SNPs are close to the fluorescent molecule, the localized electric field around the SNPs is enhanced, resulting in an increase in electron injection from cathode electrode. In addition, the enhancement factors were decreased with a decrease in thickness of the spacing layer, in the condition of thickness of spacing $< 7$ nm because the amounts of SNPs penetration into EML are of considerable enhancement, resulting in the emission quenching of the device. It is also observed that the maximum enhancement factor is obtained when the Förster energy transfer efficiency is 50%. The relationship between the Förster energy transfer efficiency and the spacing distance can be expressed as follows [16]:

$$ E = \frac{1}{1 + (R/R_0)^6}, $$

(1)

where $E$ is the Förster energy transfer efficiency, $R$ is the spacing distance between the EML and SNPs, and $R_0$ is the Förster radius. The formula can clearly illustrate that the Förster energy transfer efficiency is enhanced with a decrease in the spacing distance between the EML and SNPs. Moreover, the Förster energy transfer efficiency of 50% is obtained when the spacing distance is equal to the Förster radius. The Förster radius can be expressed as follows [17]:

$$ R_0 = 0.211 \left( \frac{\phi_0 n^4 J^2}{k^2} \right)^{1/6}, $$

(2)

where $R_0$ is the Förster radius, $\phi_0$ is the quantum yield of donor, $n$ is the refractive index of the medium, $J$ is the normalized overlap integral of the donor and the acceptor spectra, and $k$ is the orientation of the dipoles. Therefore, the Förster radius is calculated as 7 nm by using (2). In addition, the enhancement factor of the device without a spacing layer is quite low, compared with that of the device with a spacing layer, because the device without a spacing layer has an energy transfer of 100% from the fluorescent molecule to the SNPs, resulting in considerable nonradiative quenching of exciton. The schematic diagram of the nonradiative decay process of exciton is shown in Figure 7. The nonradiative decay process of exciton will be caused because of the excitation of surface plasmon polariton modes, which propagate along the surface of the SNPs. Moreover, the excitation of surface plasmon polariton modes results in an extra nonradiative decay channel at the interface between the fluorescent molecule and the SNPs [18]. Therefore, when the SNPs are very close to the fluorescent molecule, the SNPs will not only penetrate considerably into the EML but also generate an extra nonradiative decay channel.
Excited state

Ground state

Alq3

SNP

4. Conclusion

In summary, the SNPs are introduced between the electron-transport layers, and their best performance is found to have the maximum luminance 2.4 times higher than the OLED without SNPs when the spacing distance is 7 nm. When the SNPs are close to the fluorescent molecule, the SNPs will create two advantages: (i) they will enhance the spontaneous recombination of excitons due to the subtraction in the exciton lifetime and (ii) they will enhance the electron injection because of SPRE, which will induce the enhanced localized electric field around the SNPs. Nevertheless, when the SNPs are very close to the fluorescent molecule, the SNPs contrarily will result in two disadvantages: (i) they will penetrate considerably into the EML, resulting in the emission quenching of the device because the electron transfers from the LUMO of Alq3 to the Fermi level of the SNPs, and (ii) they will cause the nonradiative decay process of exciton because the excitation of surface plasmon polariton modes results in an extra nonradiative decay channel at the interface between the fluorescent molecule and the SNPs.

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References


